

FIG. I

Title: Method And Apparatus Of Processing Surface Of Substrate

Inventor: Takayuki TOSHIMA et al. Application No.: Not yet assigned Docket No.: 19937-20036.00

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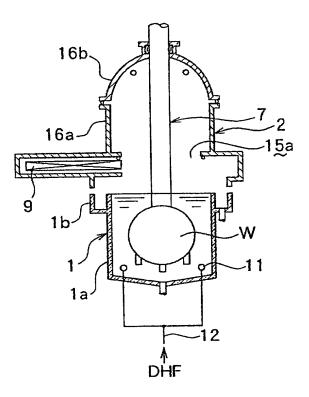
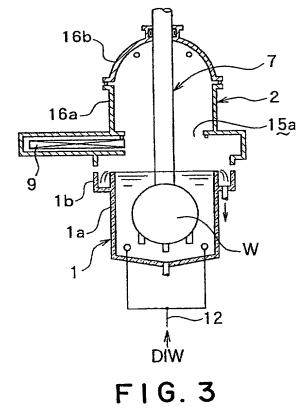


FIG. 2



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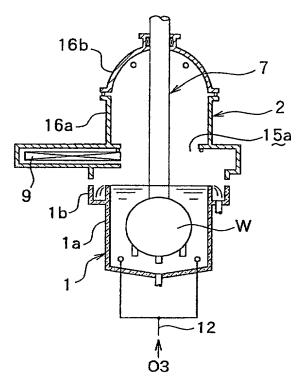


FIG. 4

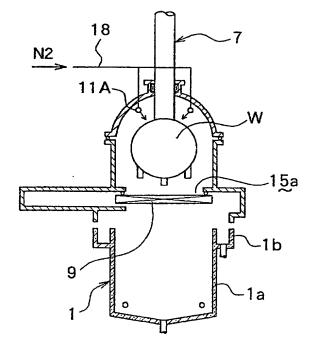


FIG. 5

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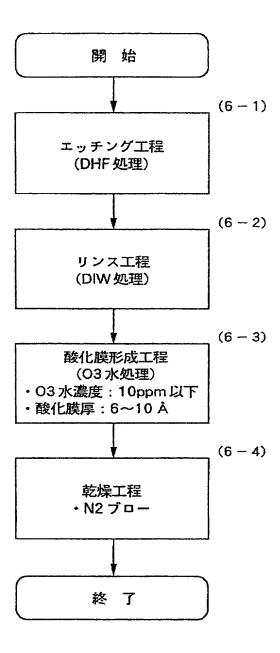
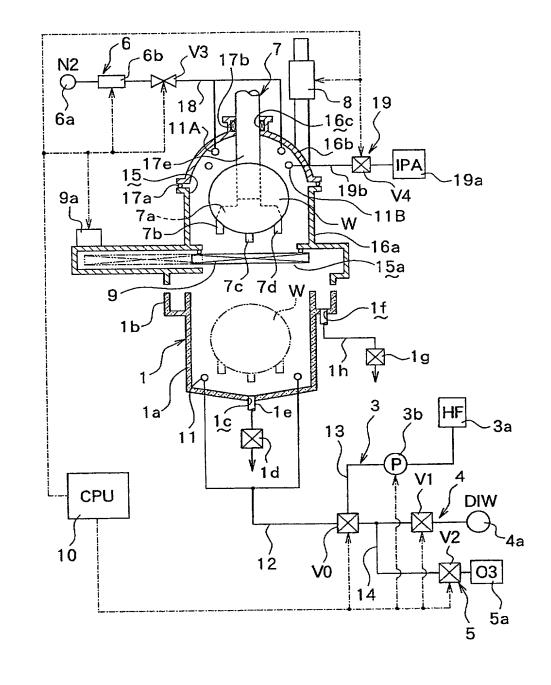


FIG. 6

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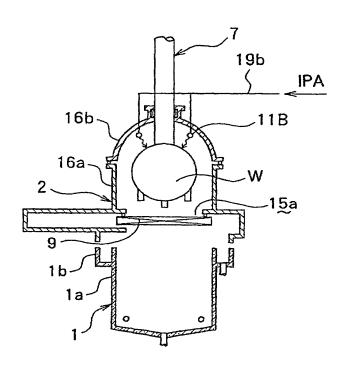


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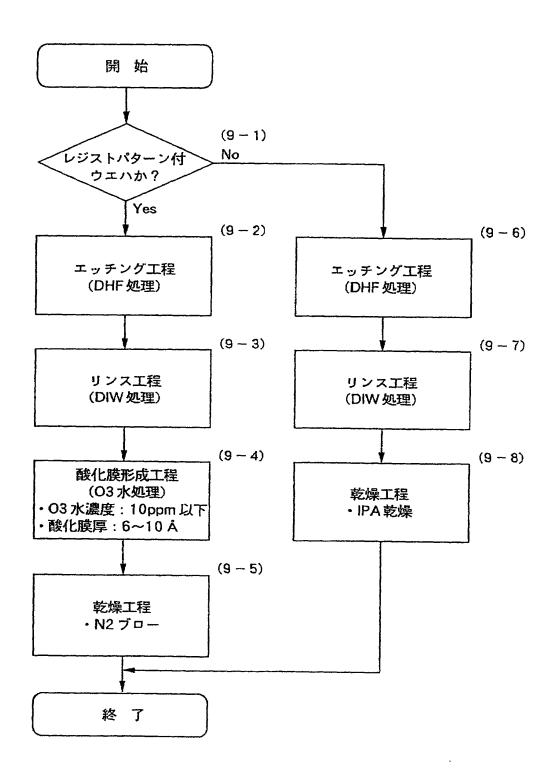


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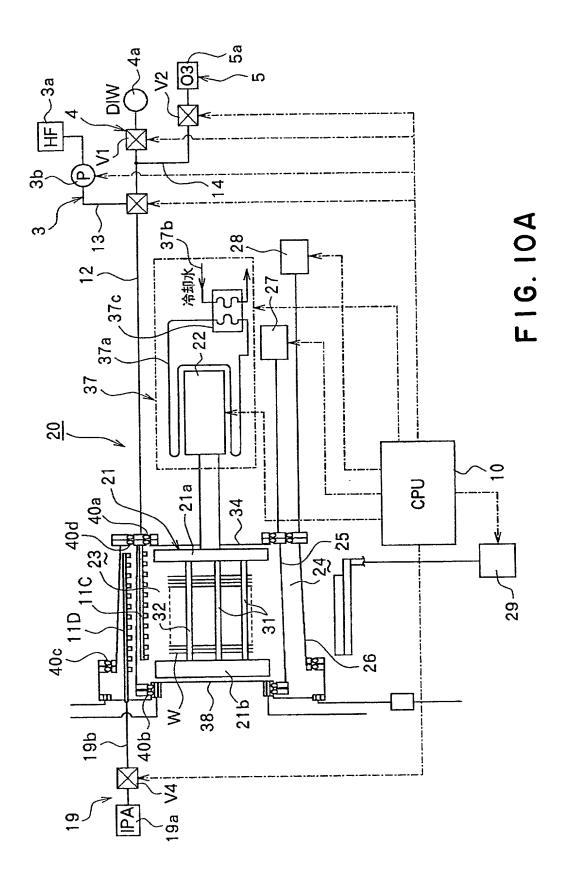


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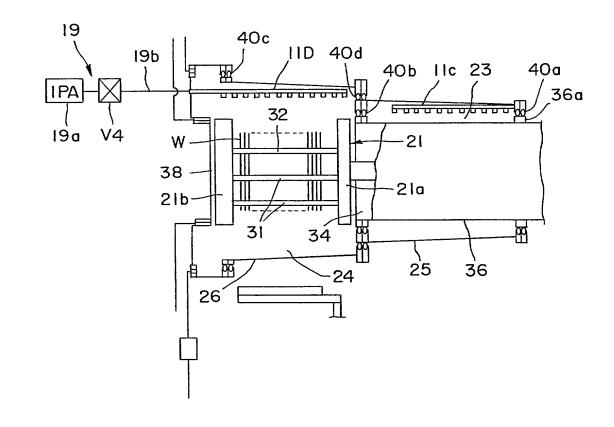


FIG. 10B

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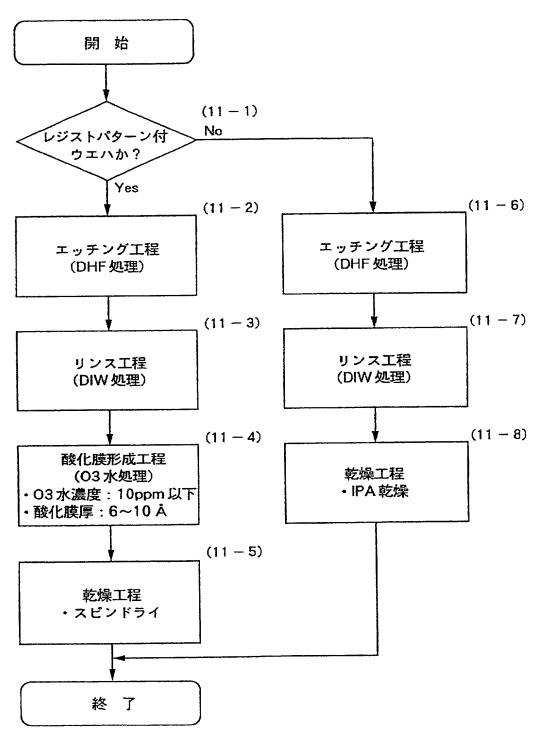


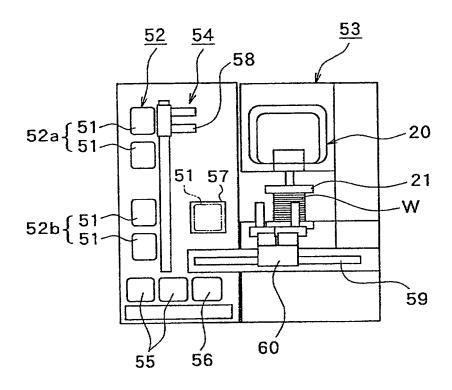
FIG. II

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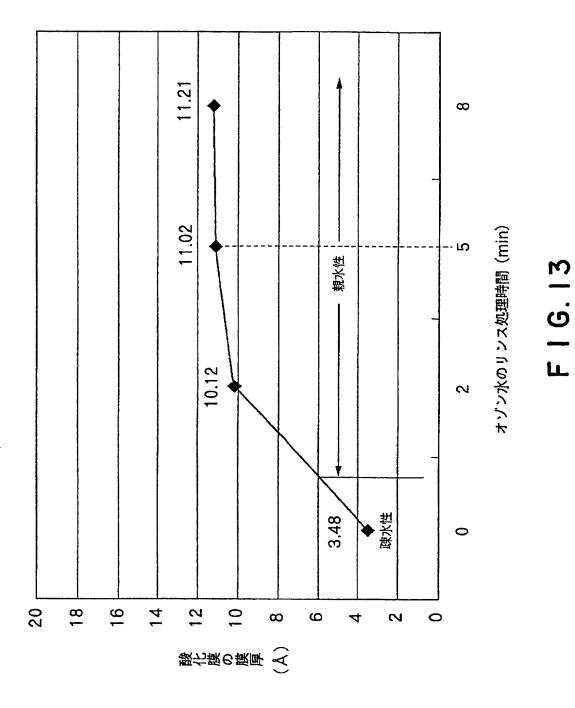
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